

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner: SALZMAN, KOURTNEY R

Group Art Unit: 1795

In re PATENT APPLICATION of

Applicants : Chen et al.

Serial No. : 10/710,698

Filed : July 29, 2004

For : PHYSICAL VAPOR
DEPOSITION PROCESS AND
APPARATUS THEREFOR

AMENDMENT

Attorney Docket: 12739-US-PA

The Commissioner is authorized to charge any fees required in connection with the filing of this paper to account No. 50-2620 (Order No.: 12739-US-PA).

AMENDMENT AND RESPONSE TO OFFICE ACTION

United States Patent and Trademark Office
Customer Service Window
Mail Stop **Amendment**
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Dear Sir:

The Office Action mailed on December 10, 2008, has been carefully and thoroughly considered. In response thereto, please enter the following amendments and consider the following remarks.